

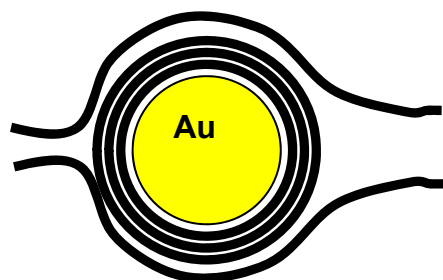
Rio Grande Symposium on Advanced Materials, Oct. 3, 2011

Synthesis of MoS₂-Au Films with Nano-Onion Like Structures

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Lubrication on Sliding Surfaces

Reduce Friction, Wear, Debris

Lubrication Enhances Reliability & Safety

Liquid lubricants can't be used on:

- Satellites
- Electromechanical Switches
- Miniature Devices



Solid Lubricants:

- High temperatures
- Vacuum compatible
- High contact pressures

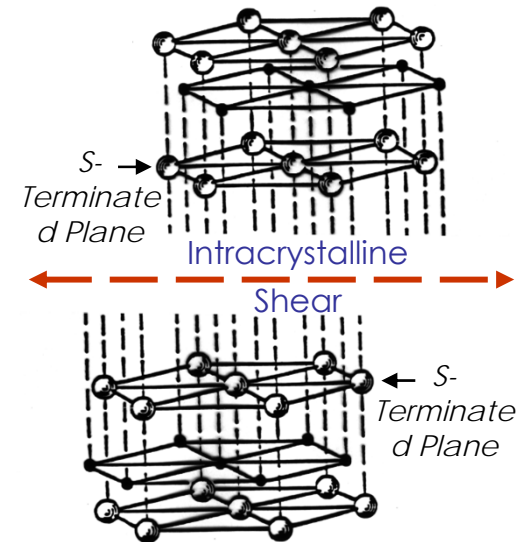


Moving Mechanical Assemblies

Solid Lubricants

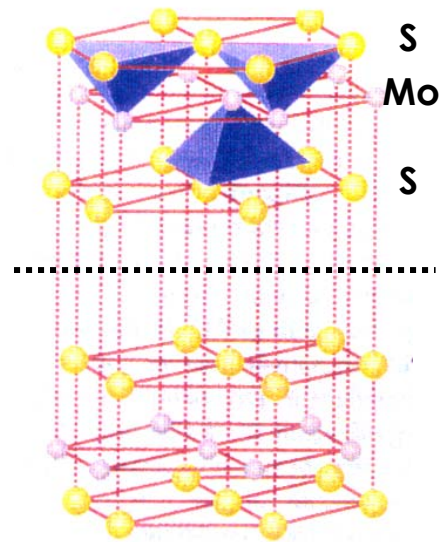
Commonly used materials

- **Lamellar Solids**
 - Transition metal dichalcogenides, graphite
- **Diamond and Diamond-like Carbon**
 - α -C:H, α -C:Si, UNCD
- **Soft Metals**
 - Pb, Ag, Au, In, Sn
- **Glasses & Ceramics**
- **Polymers**
 - PTFE, Polyimide



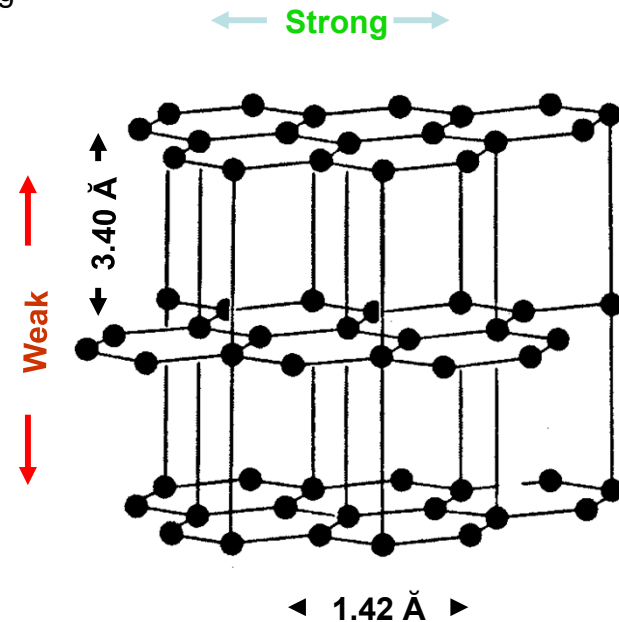
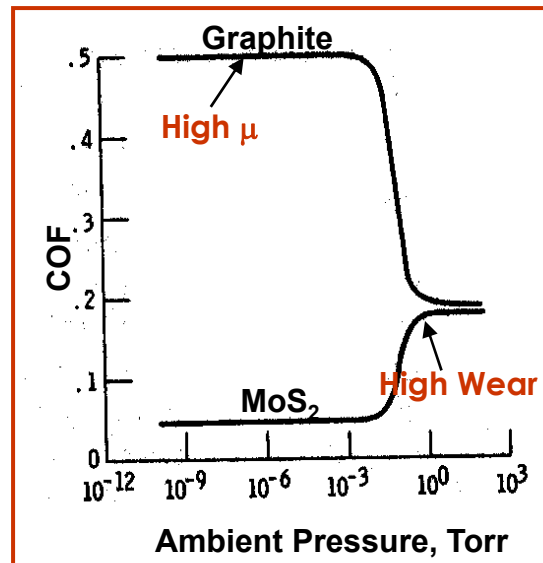
Environmental Dependence

Lamellar Solid Lubricants Environmental operating conditions



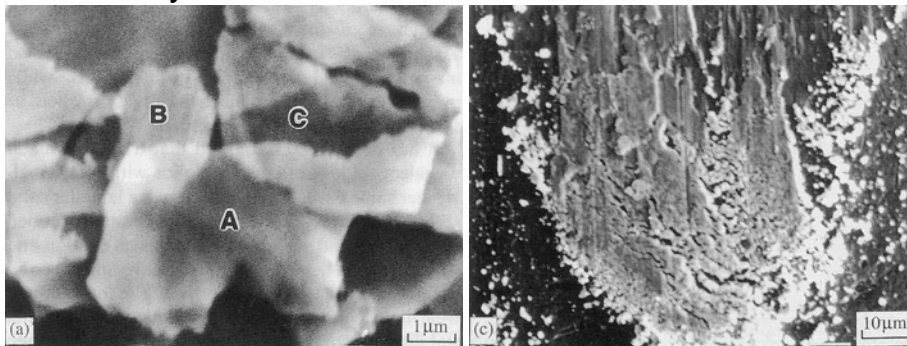
Mo/W Disulfide

MoS₂: Extremely low COF (0.01-0.05) and long wear life, **but only in dry environments.**



Graphite

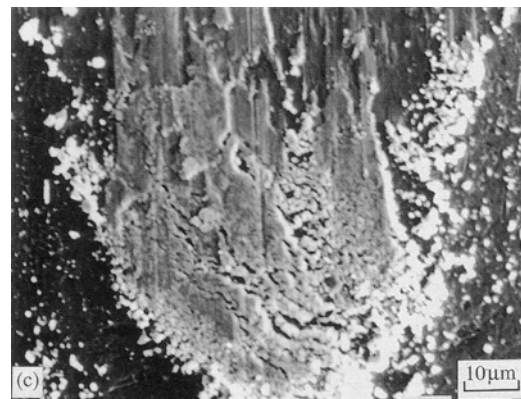
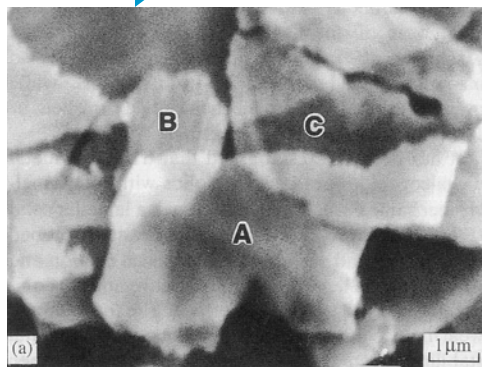
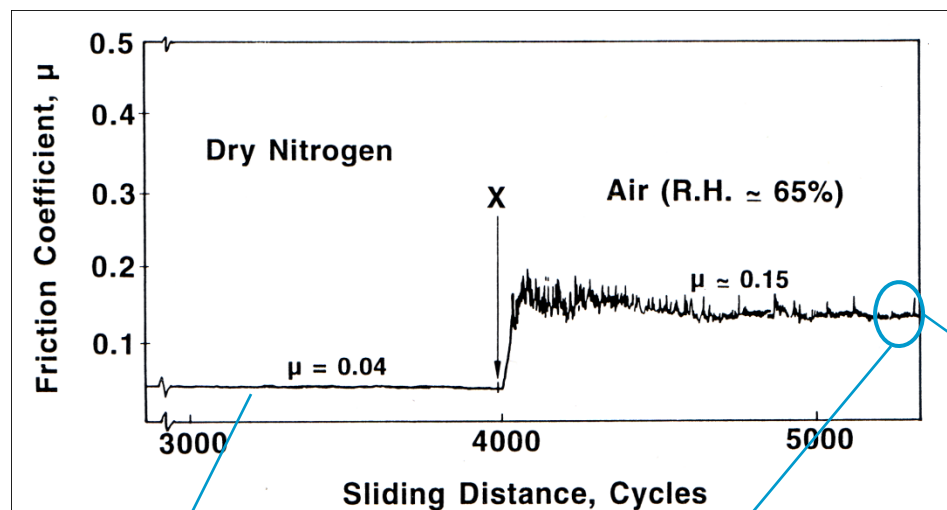
They form thin transfer films on the counterface



- Graphite needs moisture or adsorbed gases in the environment (>100 ppm) (they either act as intercalants, or passivate the dangling covalent bonds) to lubricate.
- In vacuum, graphite exhibits high friction and wear—a phenomenon known as “dusting”, first observed in the late 1930's when graphite brushes in aircrafts experienced accelerated wear at high altitudes.

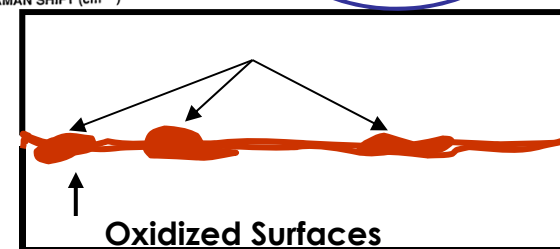
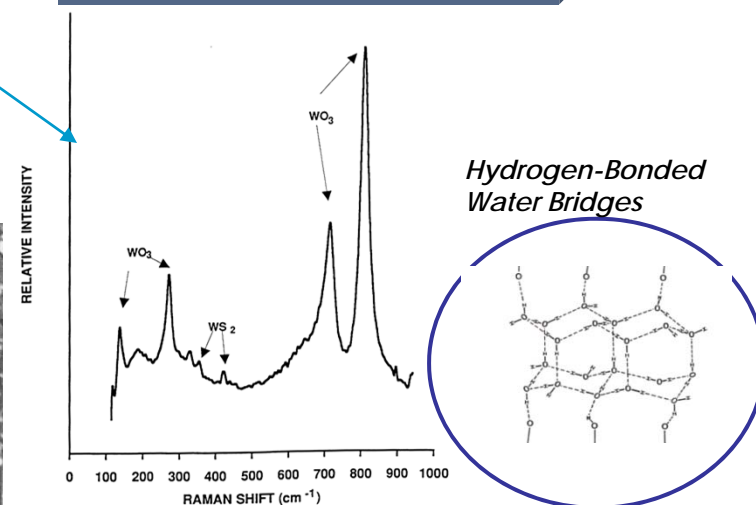
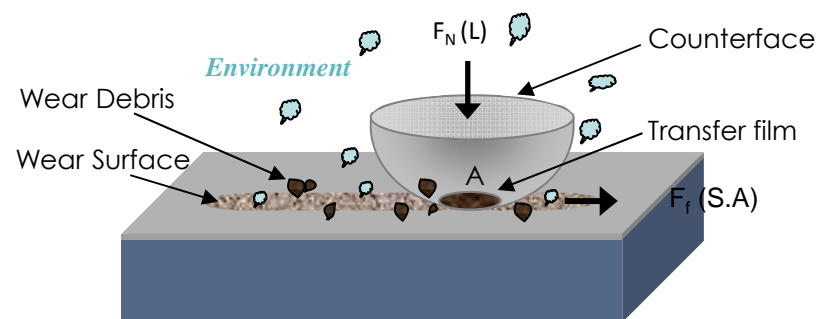
Oxidation of WS_2 in humid air

Metal dichalcogenides oxidize in humid environments



Transfer Film

SEM of Transfer Films (WS_2)



Doped MoS₂

Improved performance in humid environments

Doping MoS₂ has been shown to enhance durability in humid environments

MoS₂/titanium

-D. G. Teer, *Wear*, **251**, 1068 (2001).

-X. Wang, D. G. Teer, et. Al. *Surface and Coatings Technology*, **201**, 5290 (2007).

Mechanism not completely understood

MoS₂/Sb₂O₃/Au

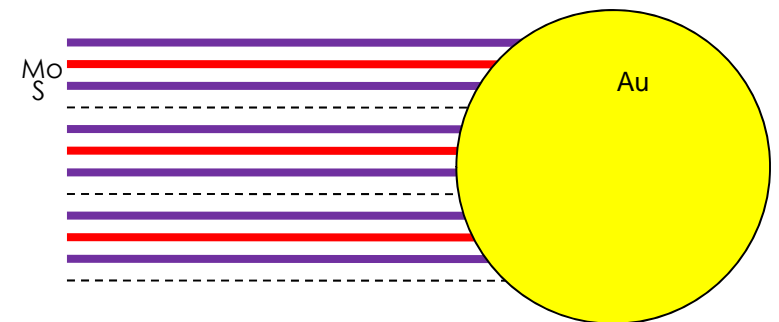
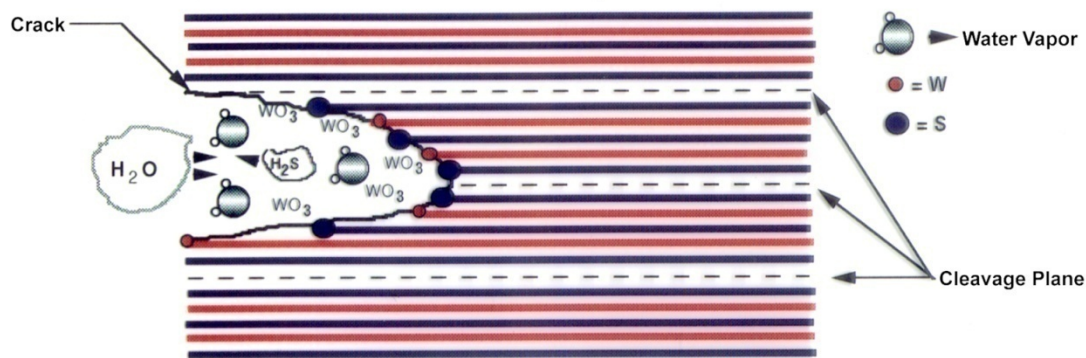
-T. W. Scharf, P. G. Kotula and S. V. Prasad, *Acta Materialia*, **58**, 4100 (2010).

Many of these doped coatings are brittle under high loads or impact

MoS₂/Au

-J. R. Lince, H. I. Kim, P. M. Adams, D. J. Dickrell and M. T. Dugger, *Thin Solid Films*, **517**, 5516 (2009).

Our approach is to build novel structures that reduce the availability of edge planes, which easily oxidize, by the addition of an inert metal using a MoS₂/Au system

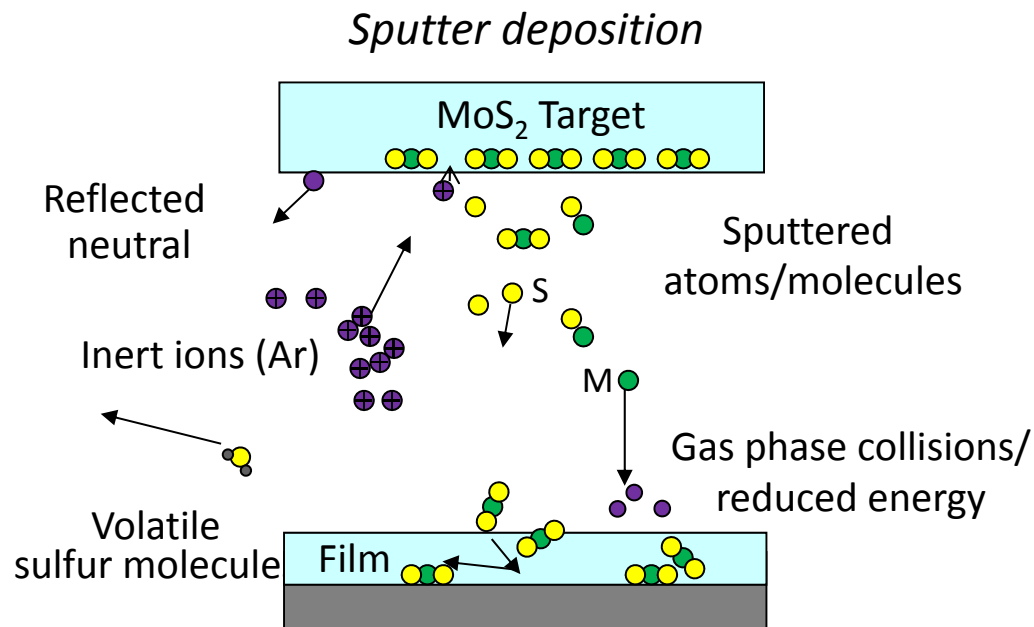


S. V. Prasad, J. S. Zabinski and N. T. McDevitt, *Tribology Transactions*, **38 (1995)**

MoS₂ Coatings

Sputter Deposition selected as fabrication technique

- **Burnishing**
- **Resin Bonding**
- **Chemical Vapor Deposition**
 - *Plasma Enhanced Chemical Vapor Deposition (PECVD)*
 - *Atomic layer Deposition (ALD)*
- **Physical Vapor Deposition**



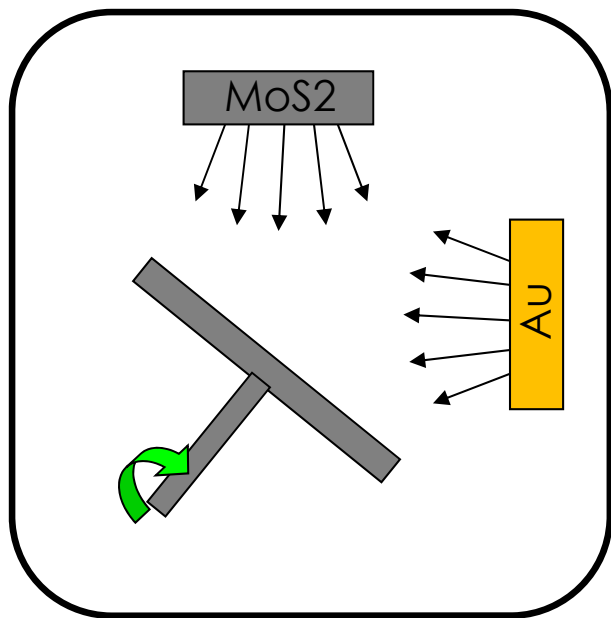
Argon gas ions are accelerated toward the (-) target/cathode resulting in the ejection of neutral target material

Sputtering offers:
Control over film properties
and composition

PVD Co-Deposition

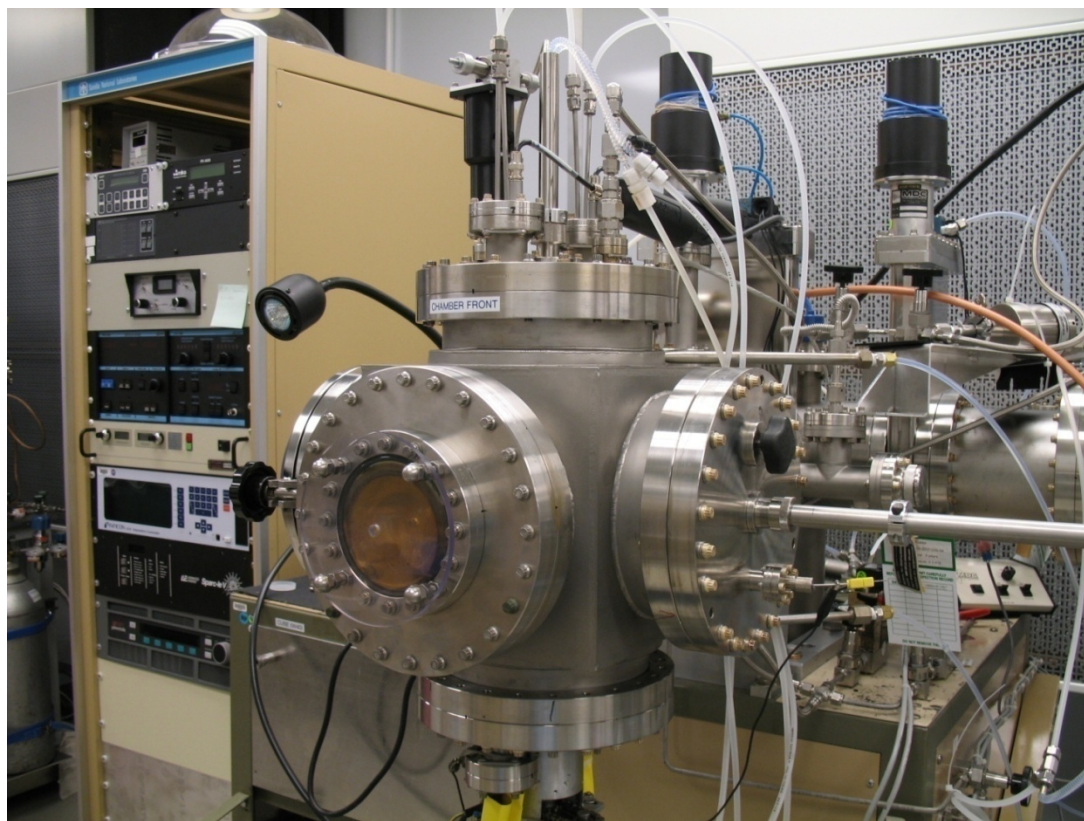
Two Targets at 90°

Sputter targets located at 90° to each other and ~45° to the substrate stage



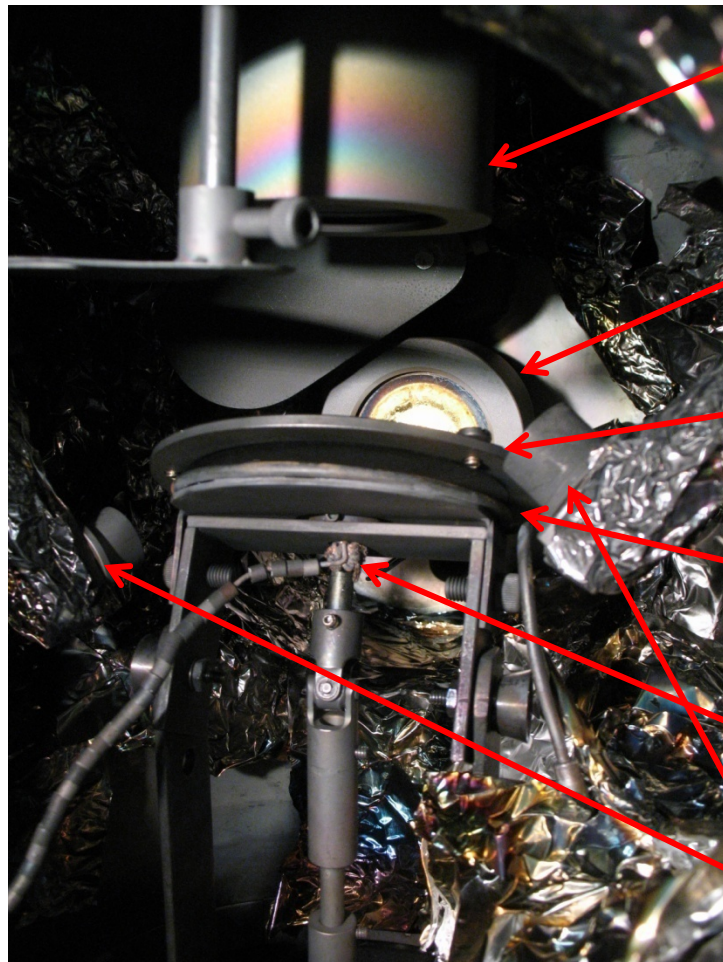
Independent rate control with stage rotation for uniformity

Experimental sputter co-deposition system used in this study



Co-Deposition Chamber

Heat, Bias and QCM rate control



MoS₂
Cathode

Au
Cathode

Rotatable
Sample Stage

Heater
($< 400^{\circ}\text{C}$)

DC Bias
-300V

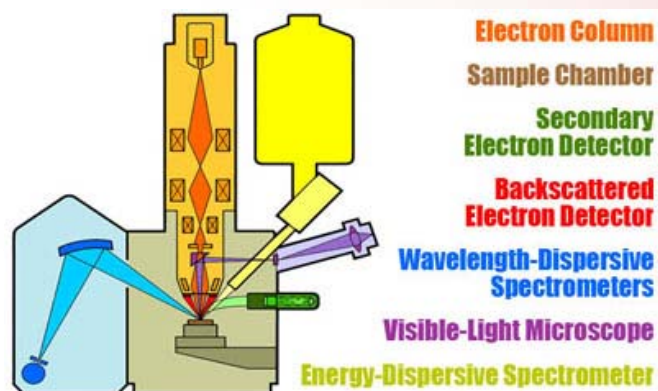
QCM Rate
Monitor/Control



Glow Discharge
on MoS₂ target

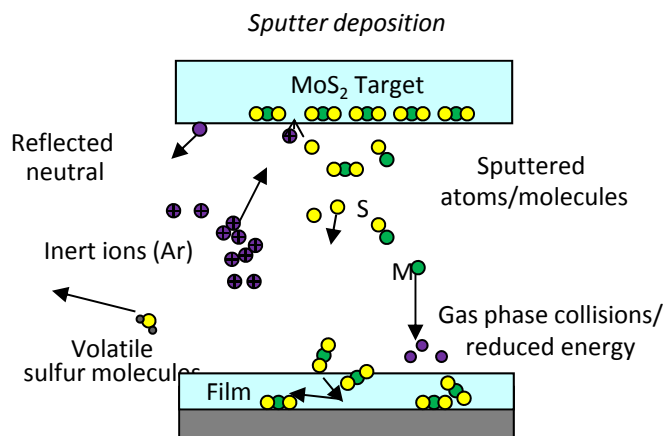
Mo:S Stoichiometry

Electron Probe Micro Analysis (EPMA)



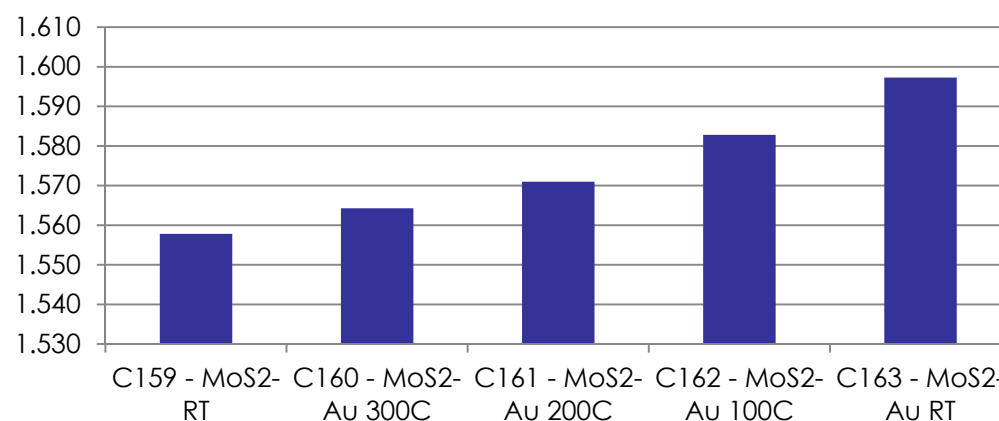
Thin films are
Sulfur deficient $\sim \text{MoS}_{1.57}$

Slight dependence on run order
(residual sulfur background)



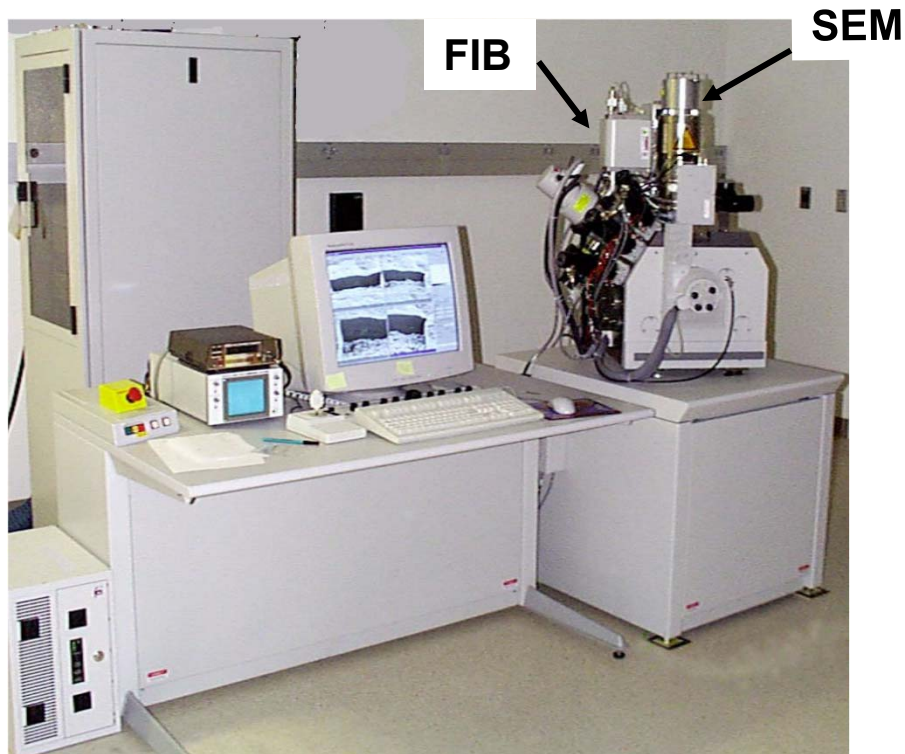
Run#	Desc	S/Mo ratio	wt% Au	vol% Au
C159	MoS2-RT	1.558	0.06%	0.02%
C160	MoS2-Au 300C	1.564	11.90%	3.03%
C161	MoS2-Au 200C	1.571	8.32%	2.13%
C162	MoS2-Au 100C	1.583	8.90%	2.28%
C163	MoS2-Au RT	1.597	9.83%	2.51%

S/Mo Ratio

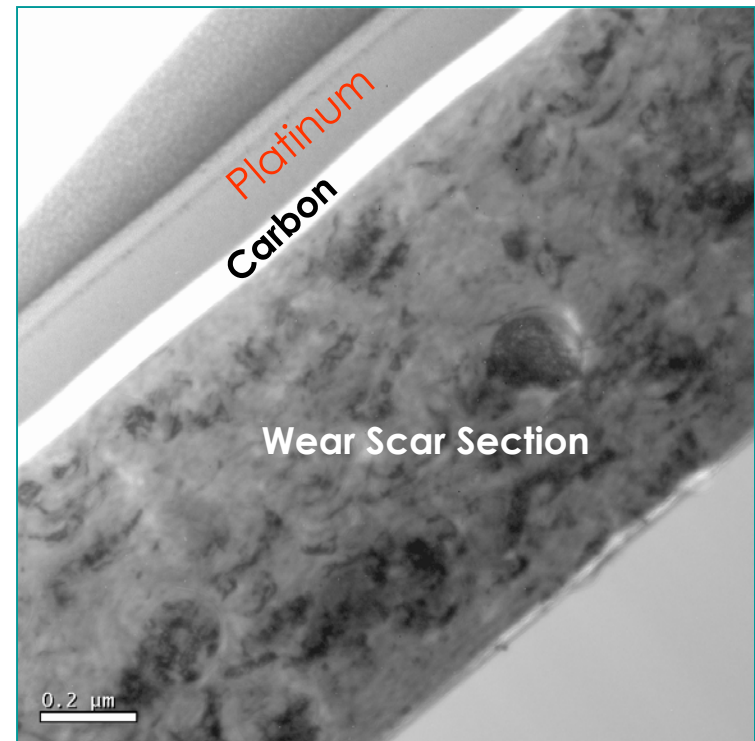
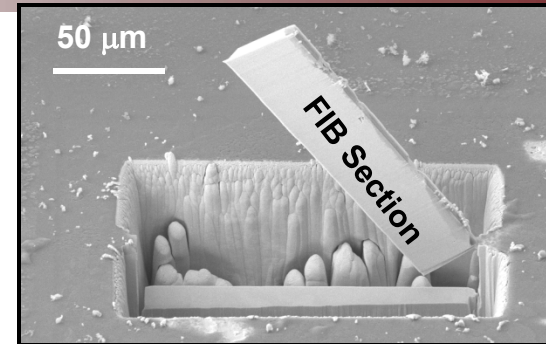


TEM sample preparation

FIB micromachining of sample cross-section



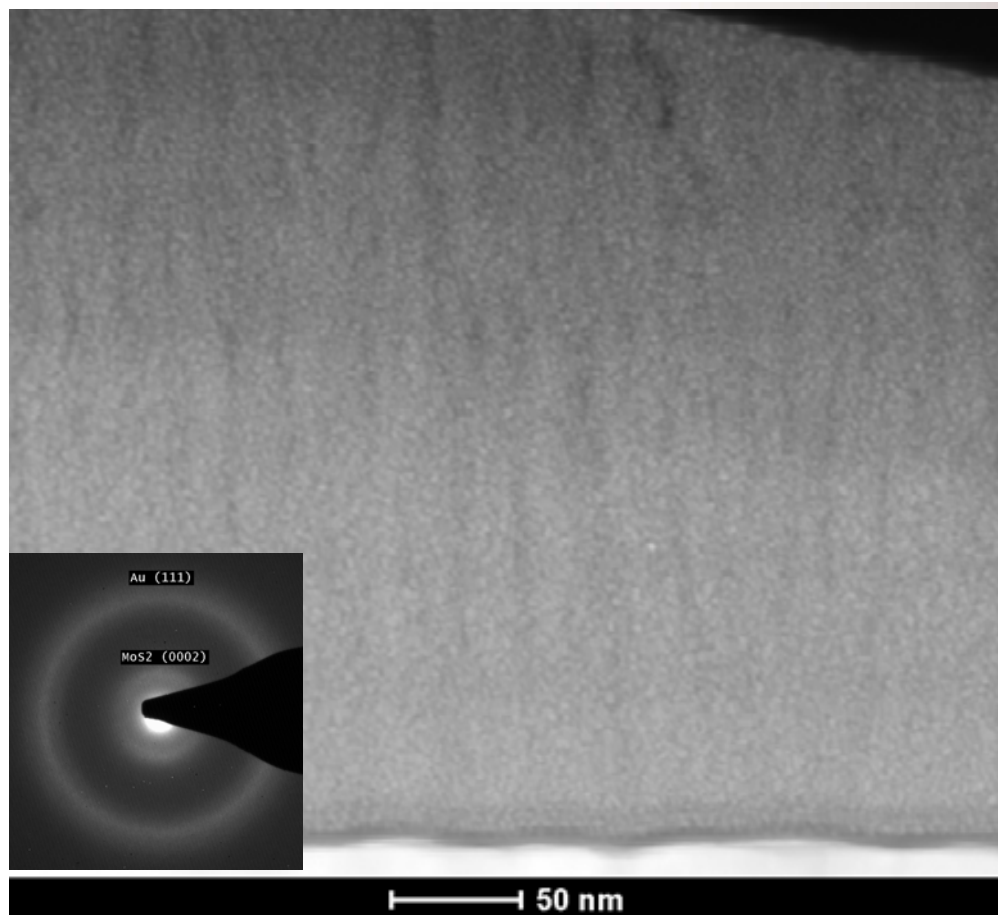
Dual-beam system from FEI: Both a FIB column and a SEM column are present on one sample chamber.



S. V. Prasad, J. R. Michael and T. R. Christensen, Scripta Materialia 48 (2003) 255-260

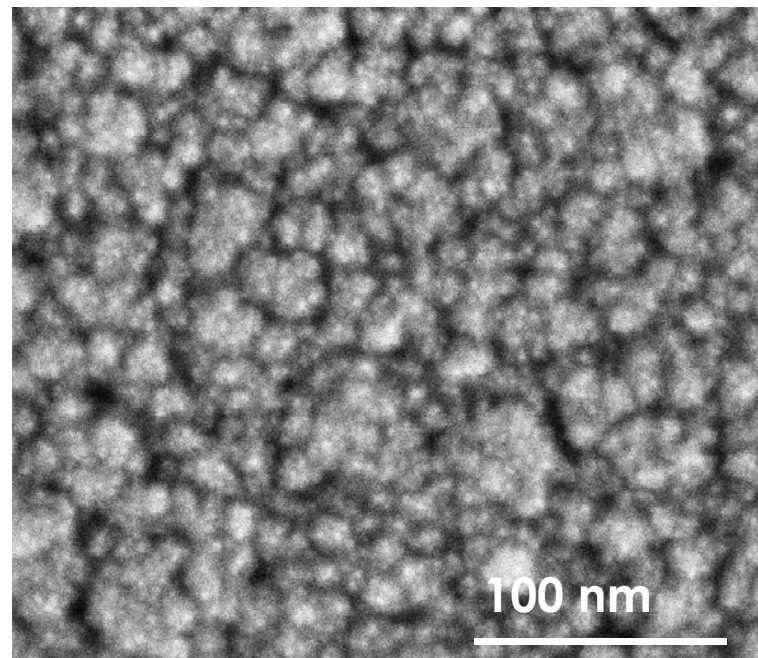
Co-Sputtered MoS₂-Au Films

RT deposition results in 2nm Au nanoparticles



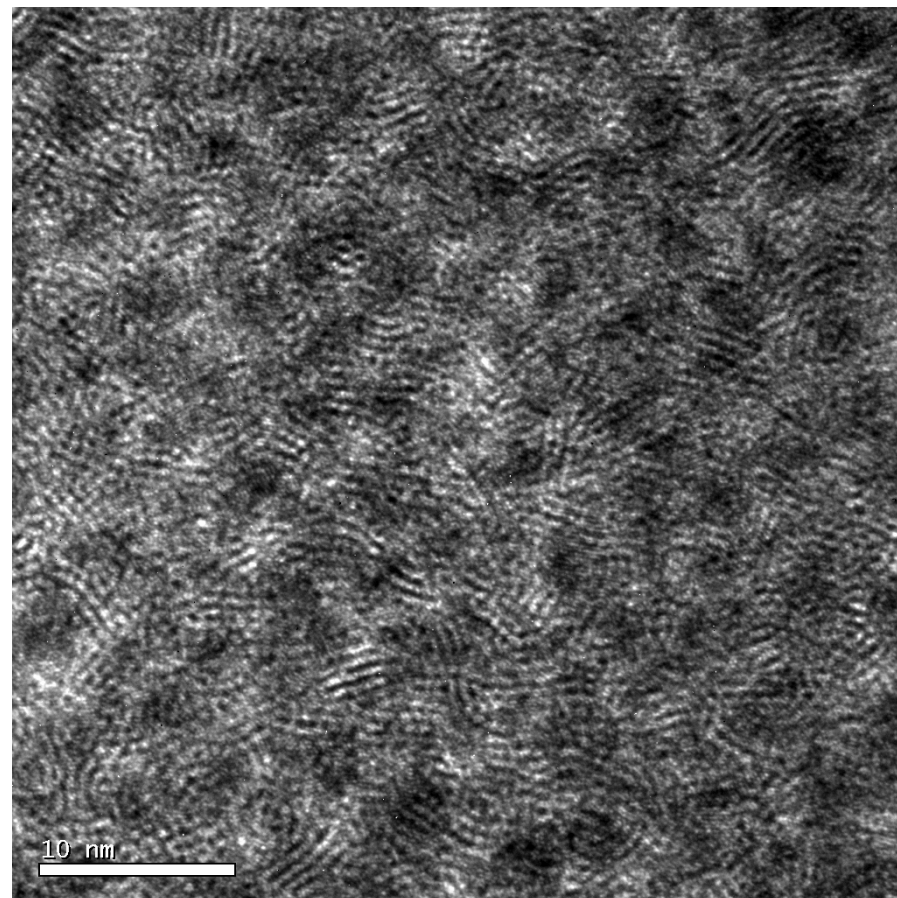
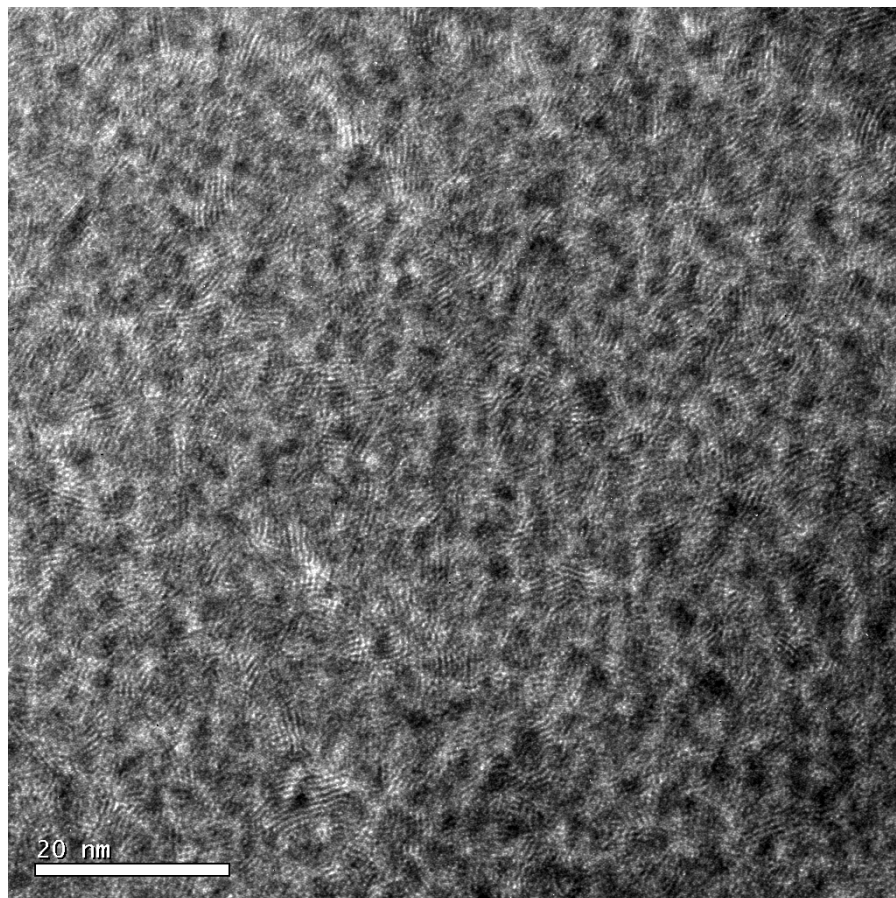
HAADF-STEM...nanocrystalline Au
(~2nm) and MoS₂
Selected-area diffraction

Plan view SEM of MoS₂ - Au RT
film, nanoparticles of Au visible
in porous MoS₂ film



MoS₂ – Au nanocomposite

Xsect HRTEM reveals nanocrystalline Au and MoS₂

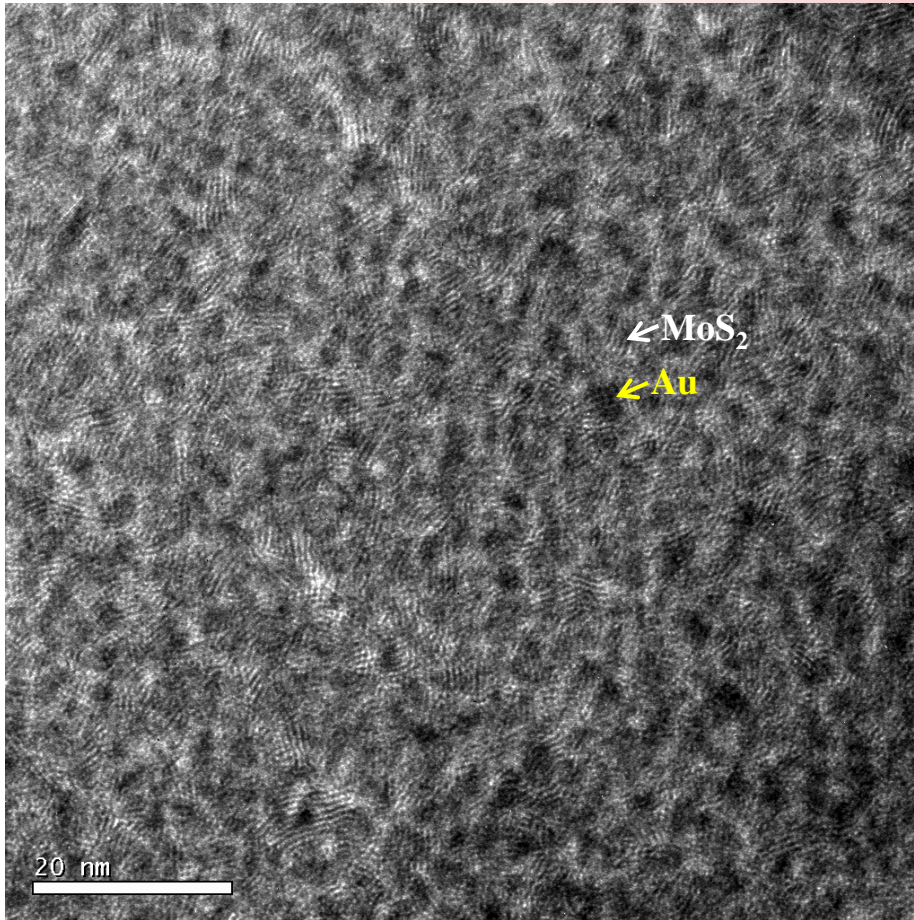


Au-MoS₂ nanocomposite deposited at room temperature.

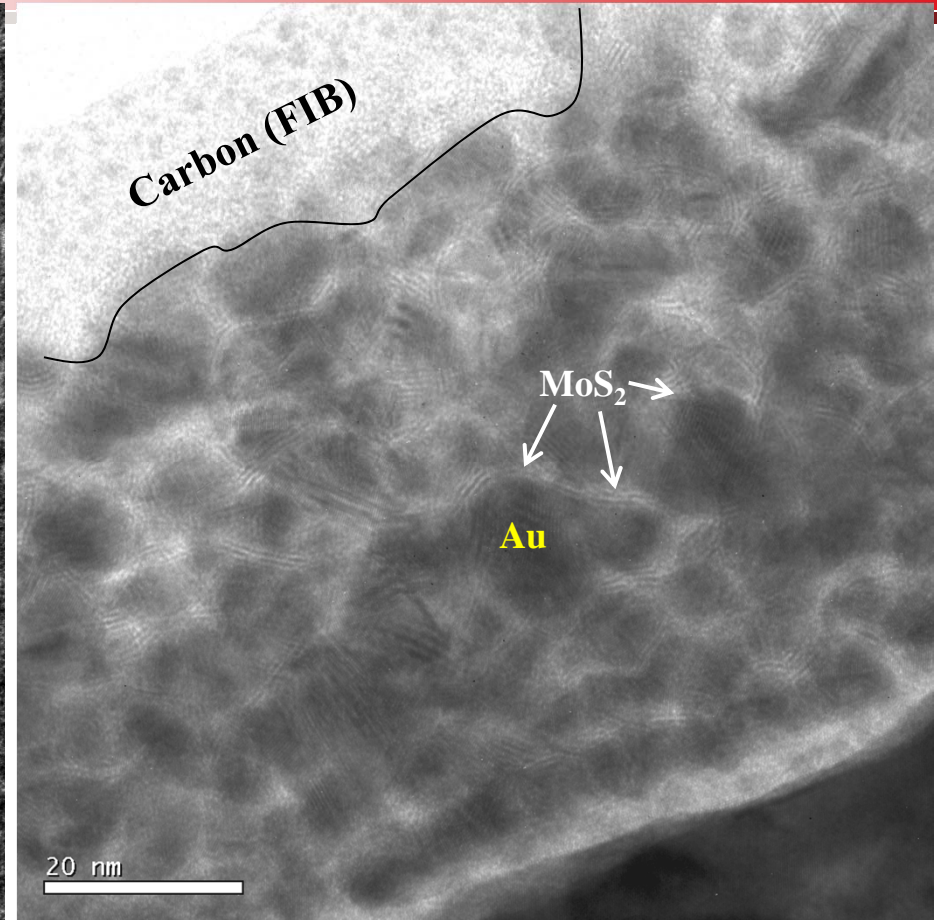
Nano-crystalline Au (~2nm) and MoS₂ (~2nm) with prominent basal lattice planes (~6Å).

MoS₂ – Au nanocomposite

Coarsening of Au nanoparticles with temperature



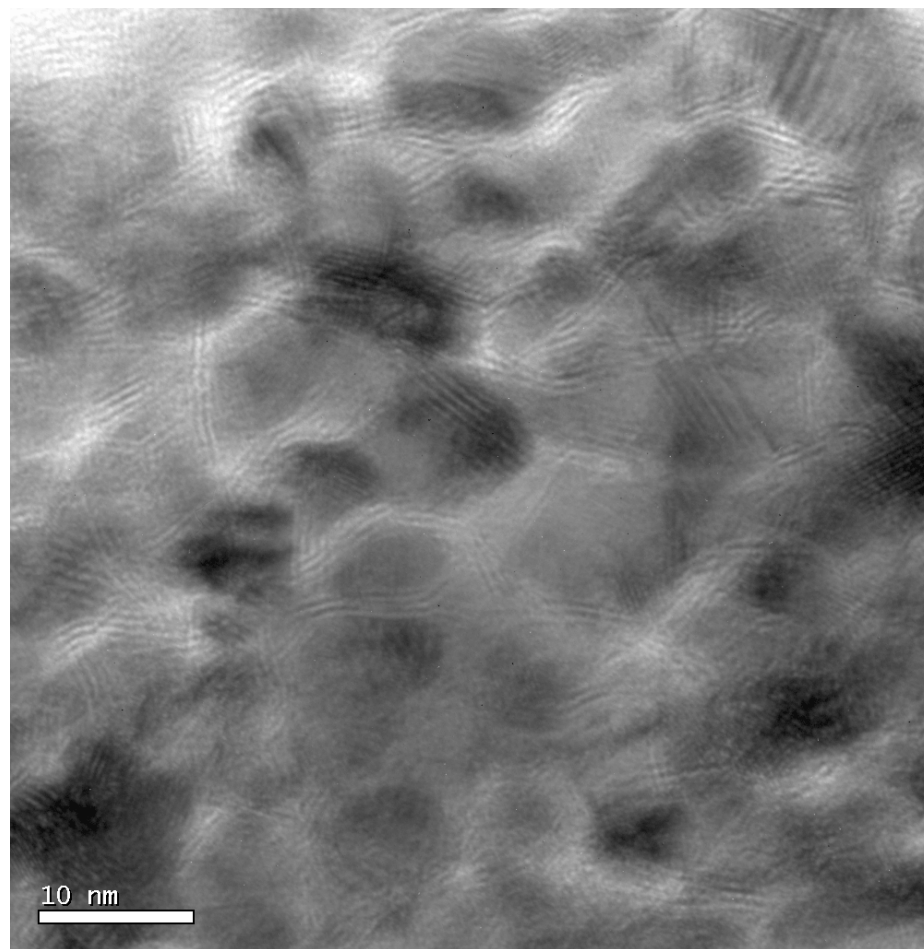
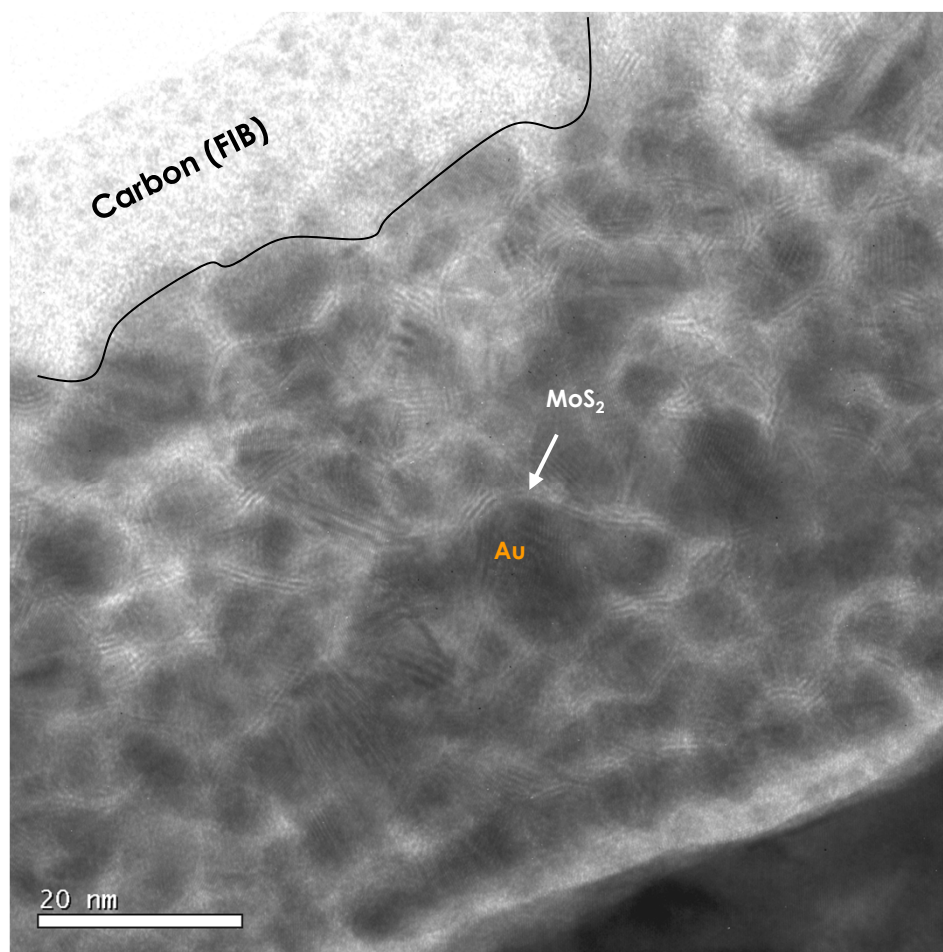
Room temperature deposition
2 nm Au & MoS₂



200°C deposition: Au coarsened to 10 nm and MoS₂ basal lattice planes thermally evolved to encapsulate the Au forming a closed MoS₂ shell (Au seed MoS₂ nano-onions.)

MoS₂-Au nano-onions

MoS₂ basal planes wrap around Au nanoparticles

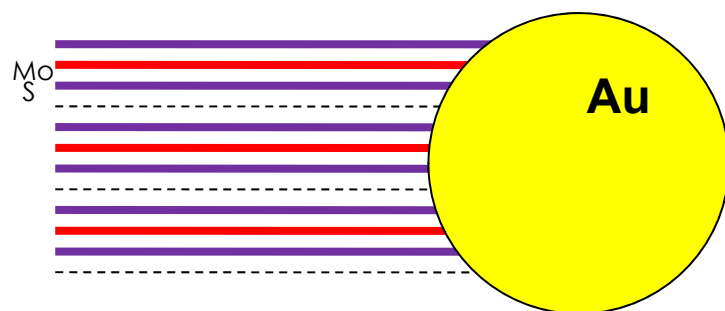


Cross-sectional BFTEM images of the Au-MoS₂ nanocomposite grown at 200°C. Nanocrystalline Au (~10 nm) core with MoS₂ basal plane closed shell. The top layer corresponds to protective carbon layer.

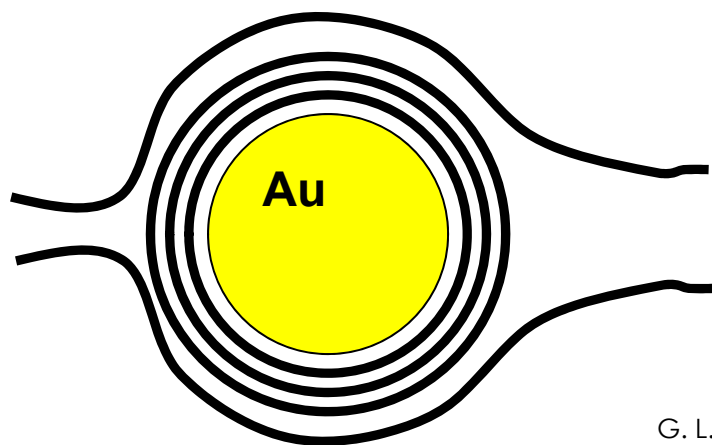
Reduced Edge Planes

Similar to IF-MoS₂

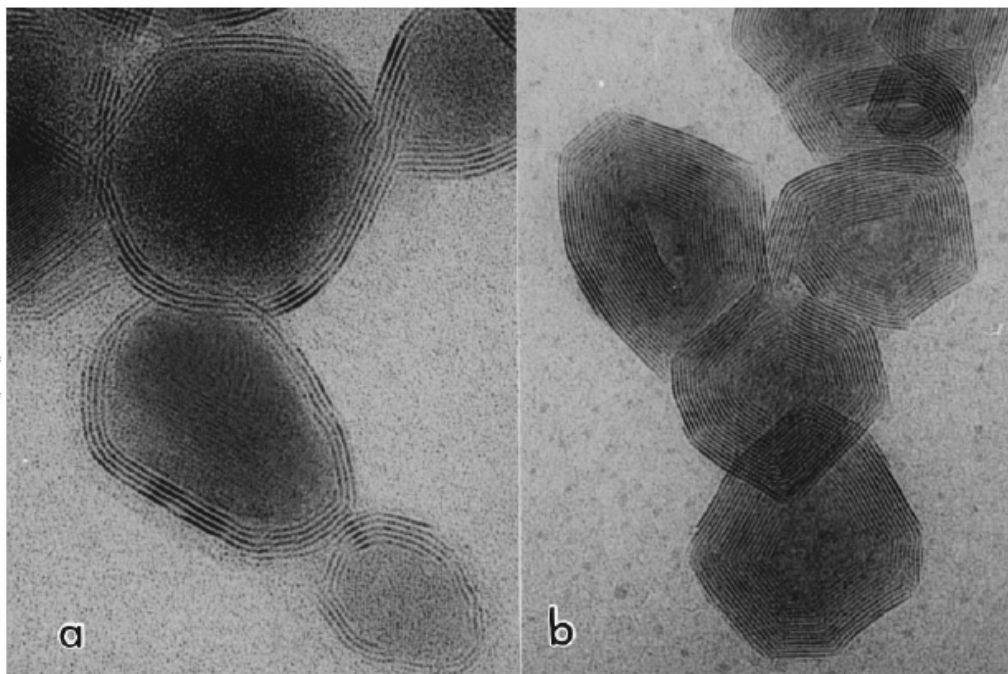
Initial objective



Experimental Result



Inorganic Fullerenelike MoS₂ or IF-MoS₂

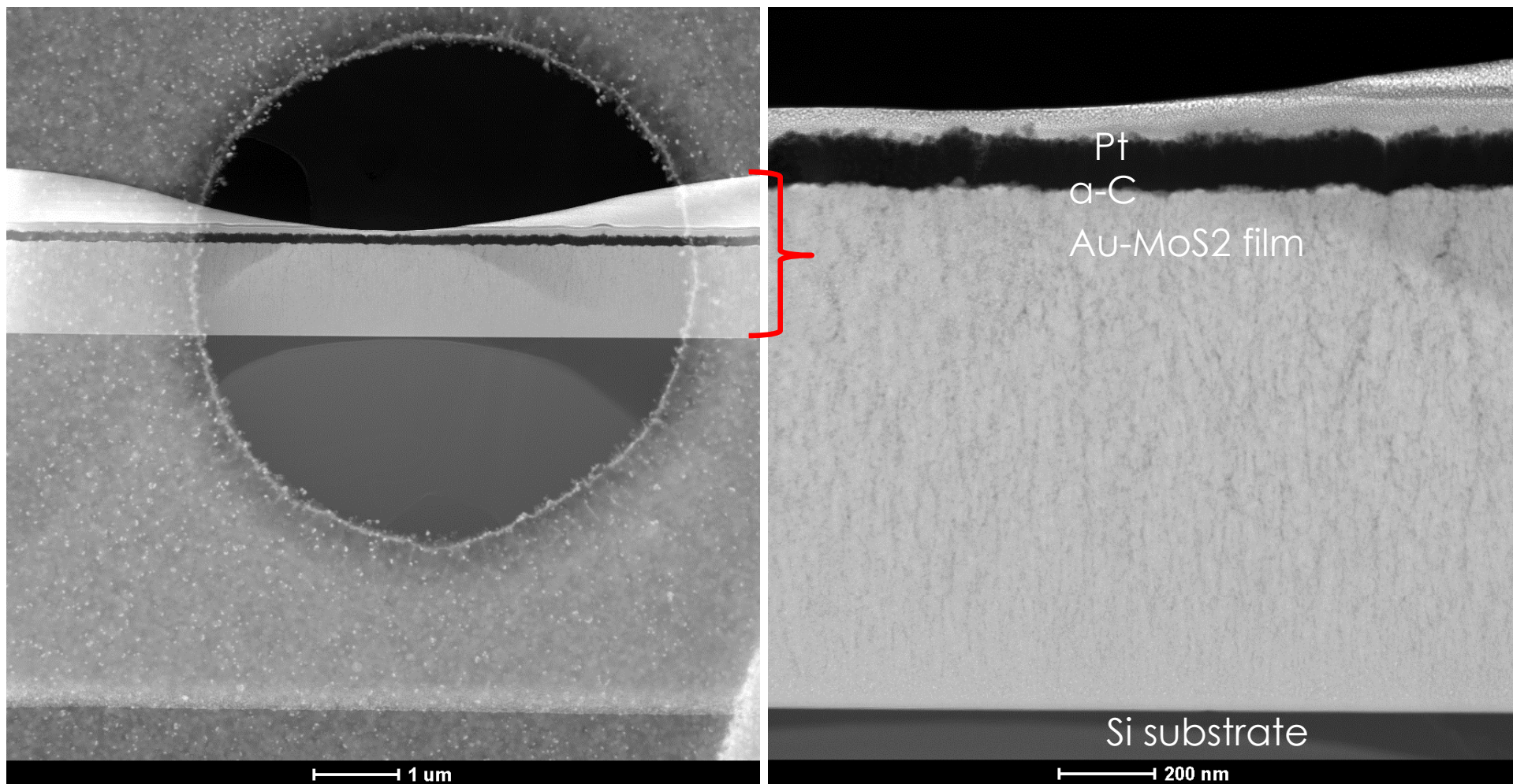


From annealing MoO₂ in H₂S atmosphere

G. L. Frey, S. Elani, M. Homyonfer, Y. Feldman and R. Tenne, *Physical Review B*, **57**, 6666 (1998)

In-situ TEM heating

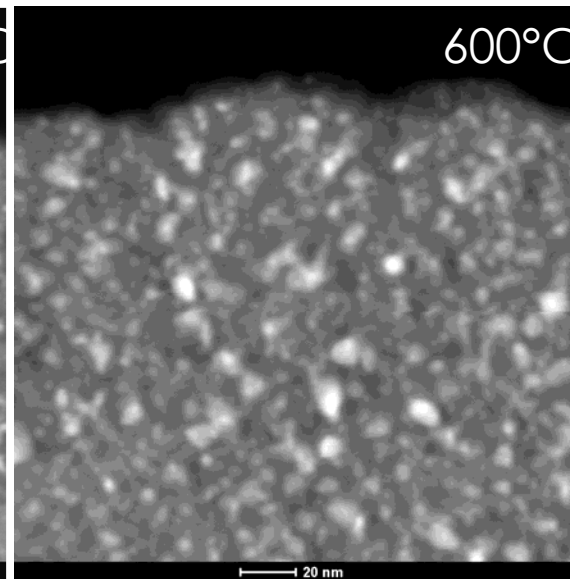
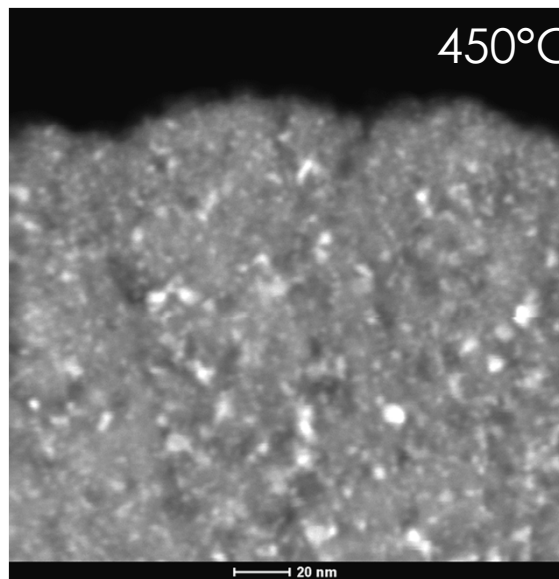
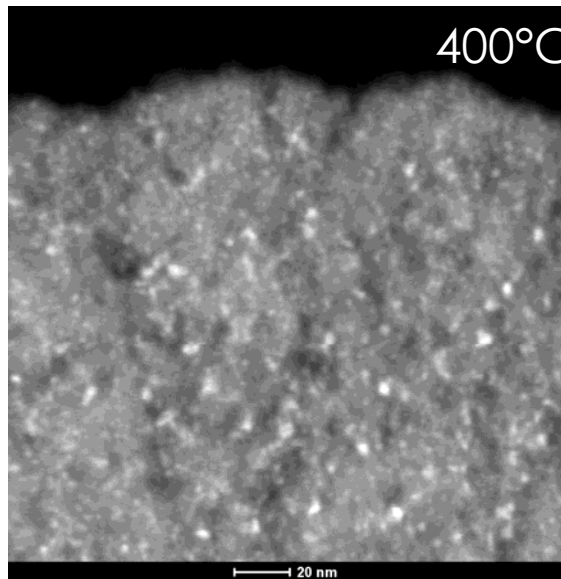
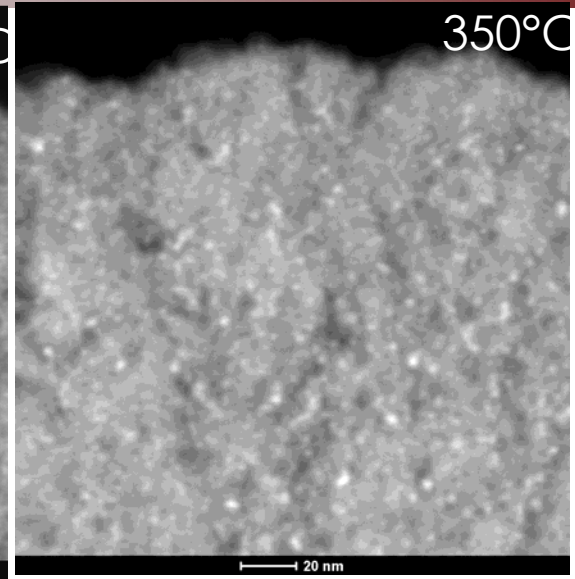
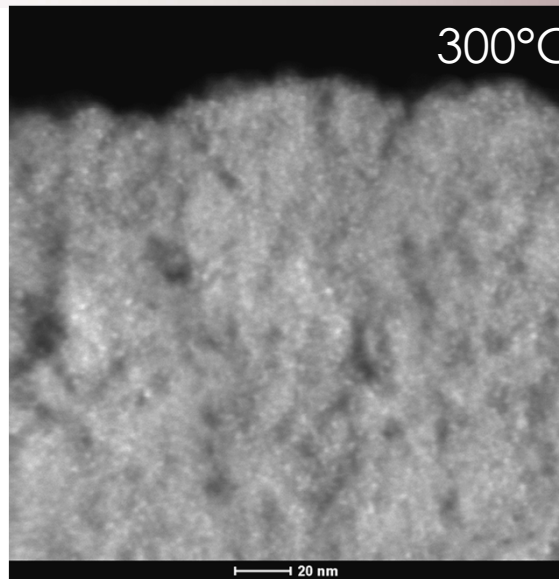
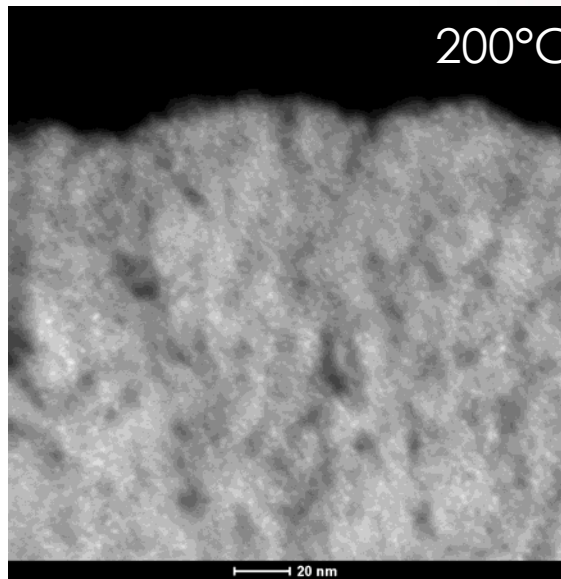
X-section sample heated post deposition in TEM



Protochips Aduro in situ TEM heating stage showing sample cross-section over electron transparent hole.

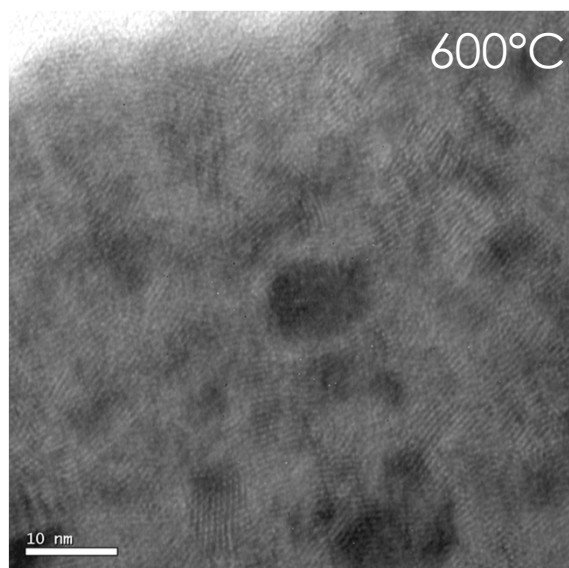
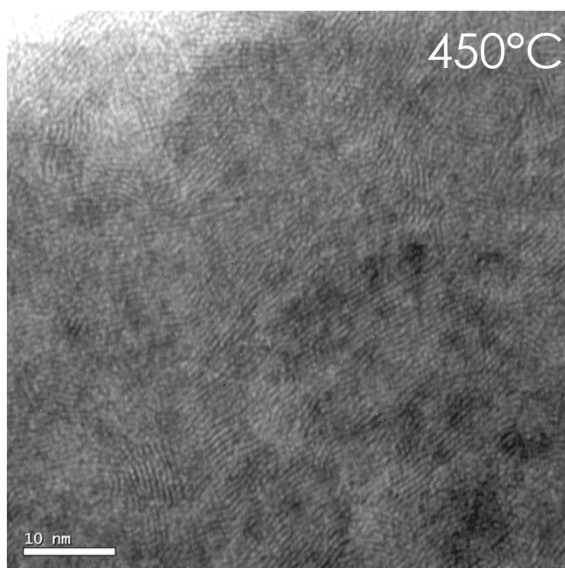
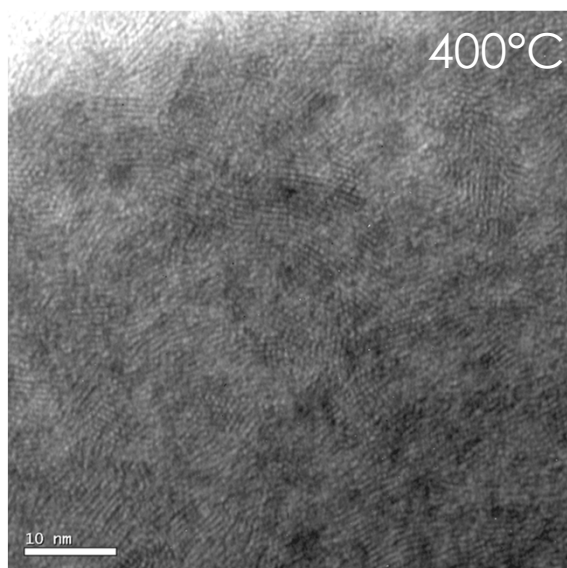
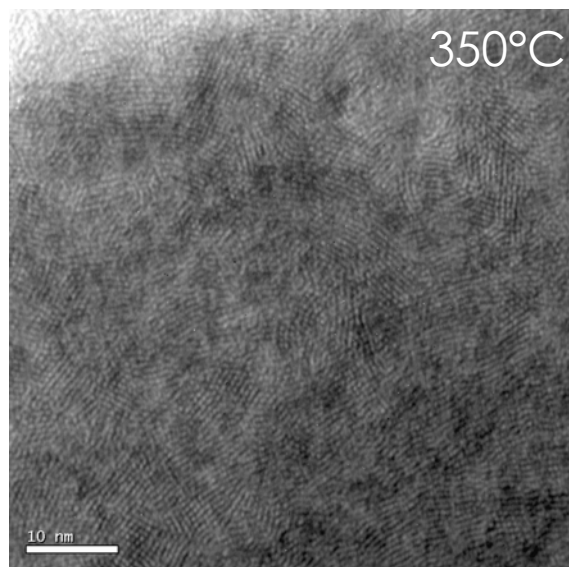
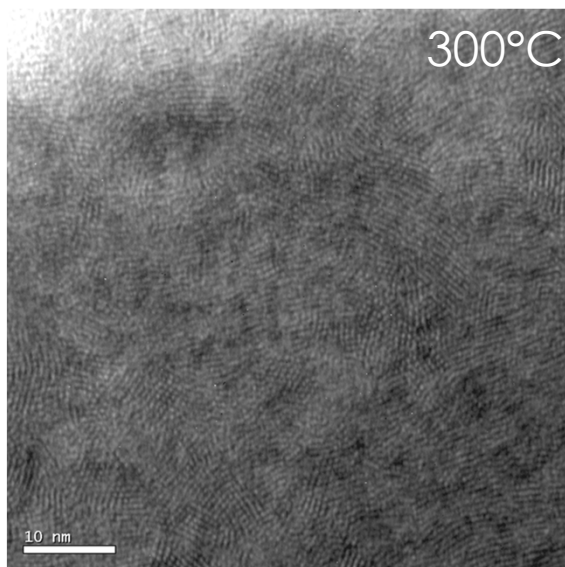
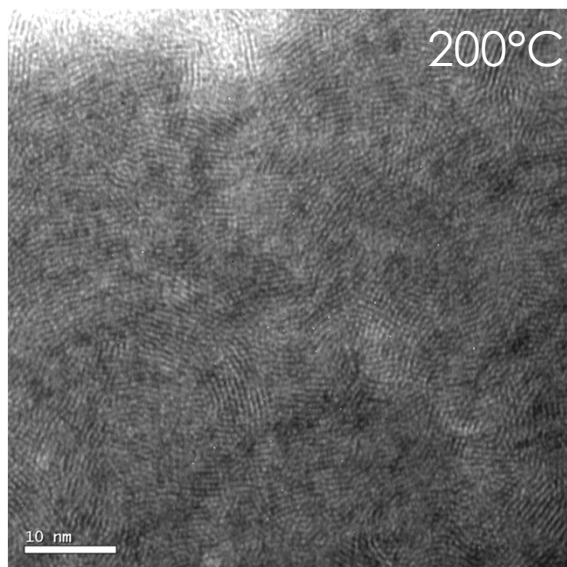
STEM/HAADF in situ heating

Film densification and Au coarsening visible



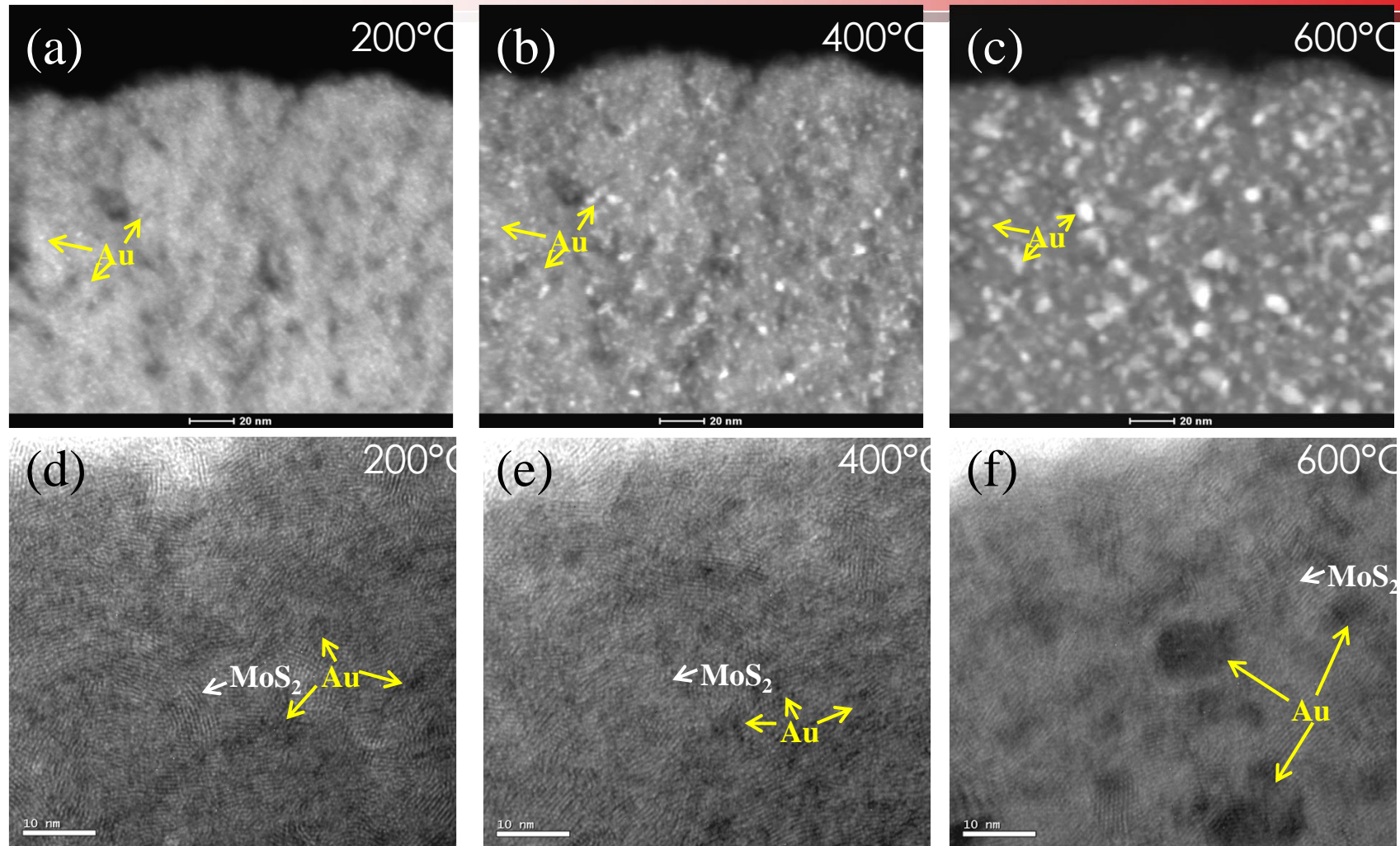
HRTEM in situ heating

No closed MoS₂ basal plane shell formation



TEM In situ heating

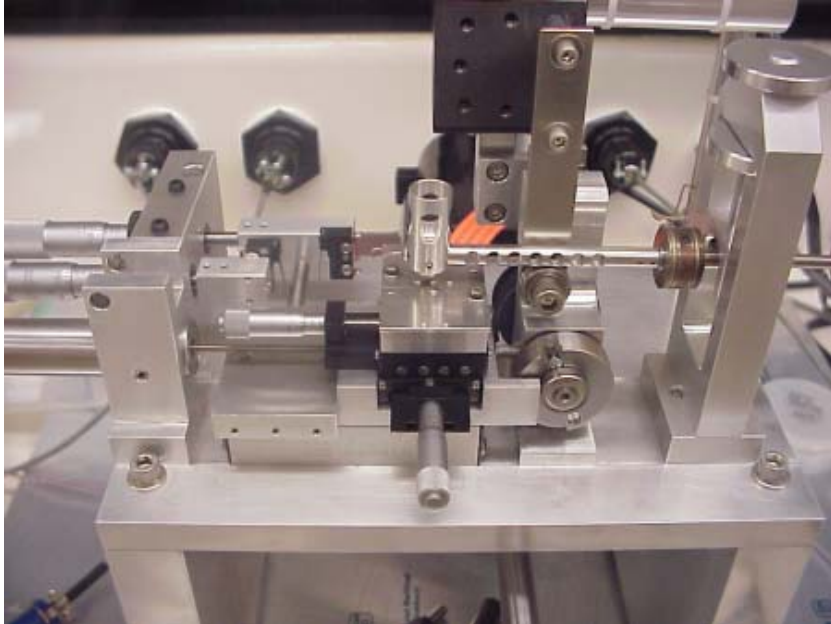
Comparing HRTEM – STEM/HAADF



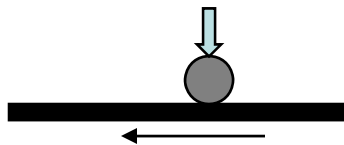
(a)-(c) STEM/HAADF images of Au coarsening and nanocomposite film densification with increasing temperature
(d)-(f) HRTEM images. Arrows indicate examples of coarsening, no shell formation

Tribological measurements

Controlled Environment Tribometer at SNL



**Linear Wear Tester
(Ball-on-Flat configuration)**



Counterfaces: Si_3N_4 Ball (3.175 mm dia)

Normal Loads: 0.95 GPa (100 grams)

Environments: Dry Nitrogen, and Air with 50 %RH

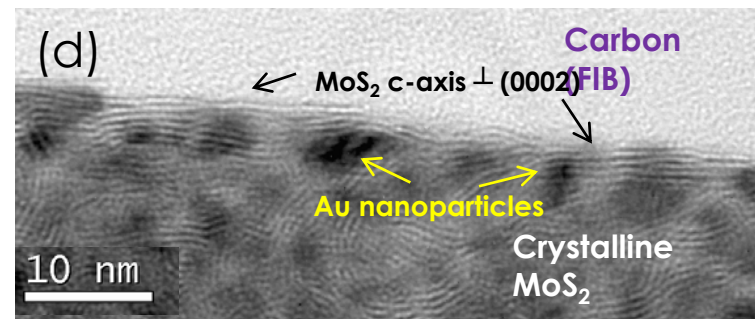
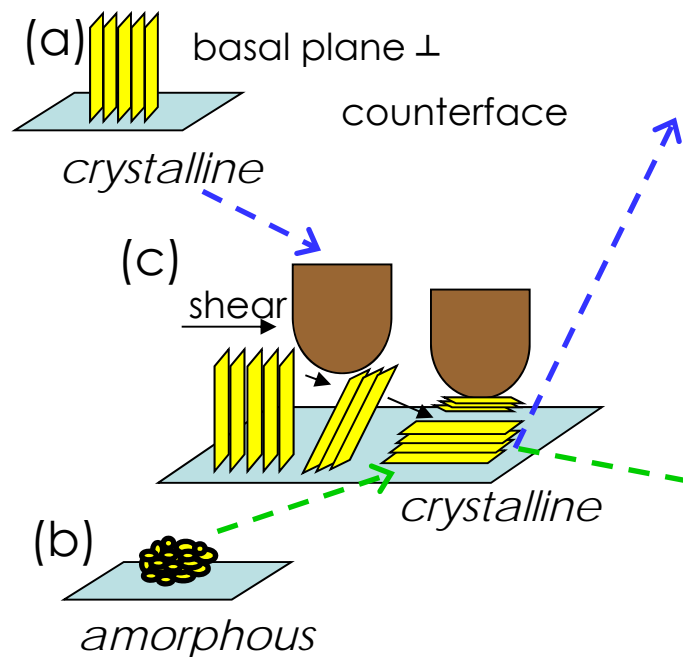


Environmental Control

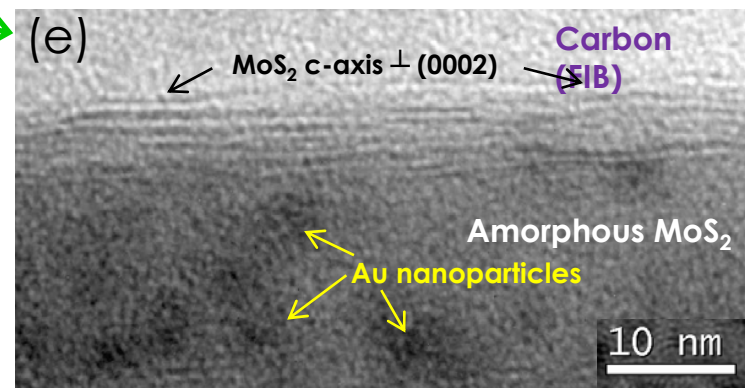
Crystallinity in Wear Scar

Shear testing creates surface parallel basal planes

(a→c→d) reorientation of perpendicular (randomly orientated) basal planes parallel to the sliding direction to achieve low friction



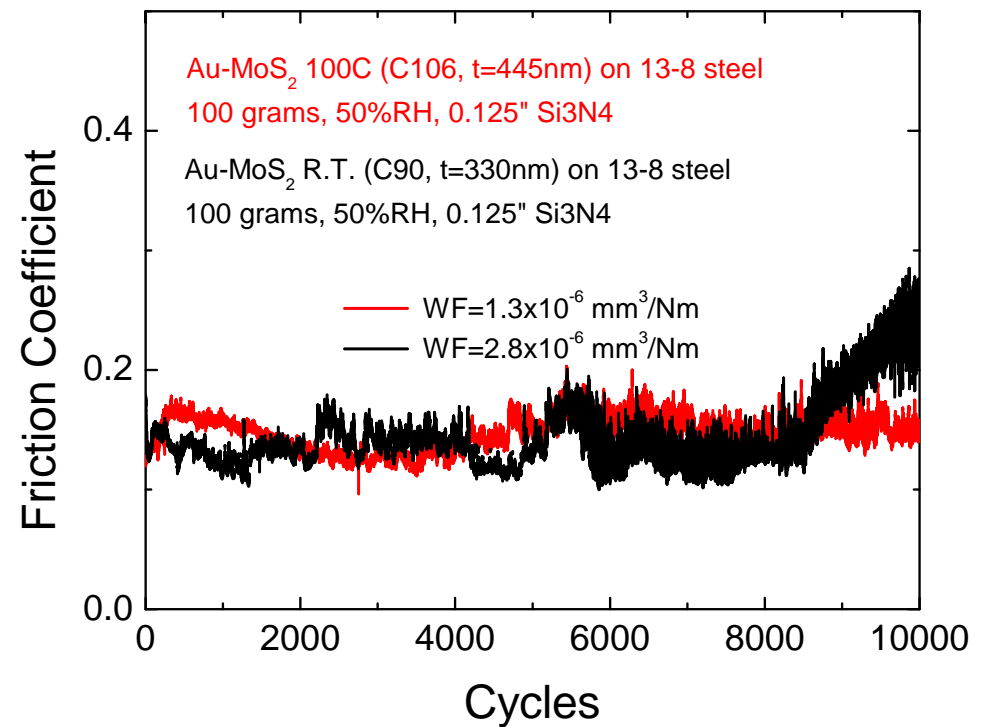
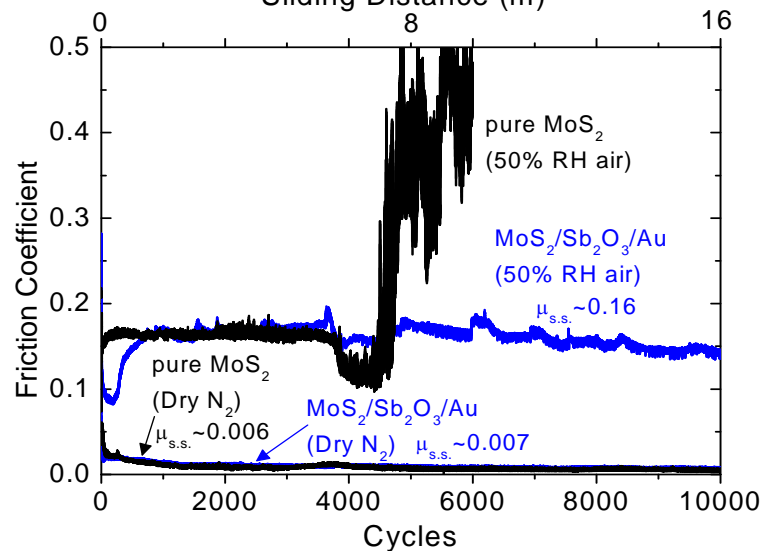
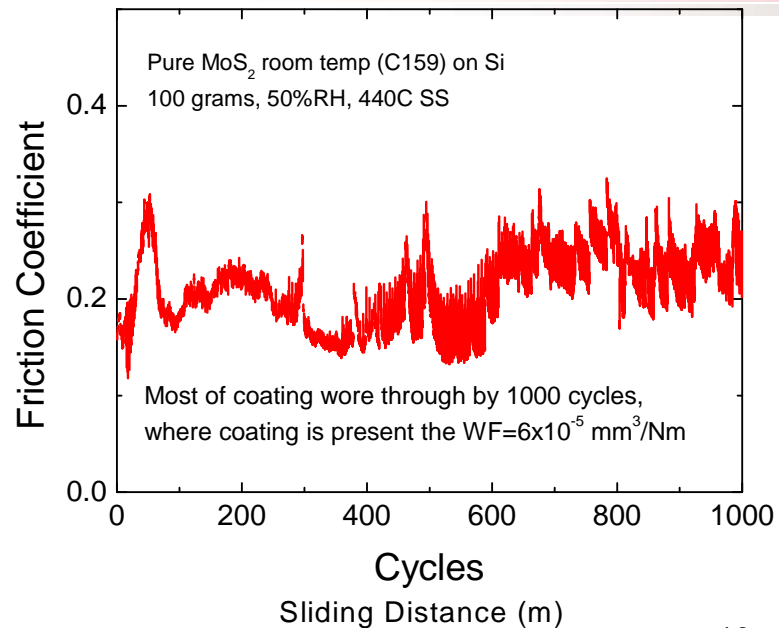
Cross-sectional TEM images inside the wear track.



(b→c→e) amorphous to crystalline transformation to achieve low friction

Friction Coefficients

MoS₂/Au films @ 50% RH



Conclusions

- Sputter co-deposition system for doped transition metal chalcogenides developed
 - Independent control of film composition
 - Substrate heating (film density, crystallinity, nano particle size)
 - Substrate biasing (film density, crystallinity)
- Novel Nano-onion like structures fabricated at 10 wt% gold enabled by deposition on heated substrate ($T_s = 200 - 300^\circ\text{C}$)
- These MoS_2/Au films exhibited enhanced performance in humid environments

Acknowledgements:

The authors appreciate the efforts by R. Grant for EPMA, C. Sobczak for thin film deposition and funding from Sandia National Laboratories.